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**TO:** Examiner Bryan R. Muller  
Examining Group 3723

**FAX NO.:** (571)-273-8300

**FROM:** Jeff Lloyd

**DATE:** January 10, 2007

**NO. OF PAGES (INCLUDING COVER SHEET):** 8

**SUBJECT/MESSAGE:**

Re: U.S. Patent Application Serial No. 10/676,643; filed October 1, 2003  
Apparatus and Methods for Slurry Flow Control  
(Kim)  
Attorney Docket No. SUN-DA-106T

**Attachment:**

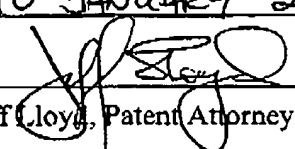
1. Amendment Under 37 CFR 1.116 (7 pages)

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10 January 2007

  
Jeff Lloyd, Patent Attorney, Reg. No. 35,589

AMENDMENT UNDER 37 C.F.R. §1.116

Examining Group 3723

Patent Application

Docket No. SUN-DA-1061

Serial No. 10/676,643

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Examiner : Bryan R. Muller  
Art Unit : 3723  
Applicant : Wan Shick Kim  
Serial No. : 10/676,643  
Filed : October 1, 2003  
Confirm. No. : 1719  
For : Apparatus and Methods for Slurry Flow Control

Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

AMENDMENT UNDER 37 C.F.R. §1.116

Sir:

In response to the Office Action dated November 16, 2006, please amend the above-identified application as follows:

J:\SUNDA\1061\PTO\Response#3.doc/RESPON/sjk